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Bib Data Sheet

CONFIRMATION NO. 5489

SERIAL NUMBER 10/812,747	FILING DATE 03/29/2004 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 20110/0200839-USO
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** CONTINUING DATA ***** YFI LV

This application is a CON of PCT/JP02/09734 09/20/2002

** FOREIGN APPLICATIONS ***** YFI LV

JAPAN 2001-299435 09/28/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/08/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 7
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>LV</i>	Initials <i>LV</i>		

ADDRESS

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TITLE

Silicon substrate etching method and etching apparatus

FILING FEE	RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
			<input type="checkbox"/> 1.16 Fees (Filing)
			<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)